



17N

Docket No.: 4249-0110P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ramam AKKIPEDDI et al.

Application No.: 10/602,714

Confirmation No.: 9942

Filed: June 25, 2003

Art Unit: 1765

For: METHOD OF CLEAVING GaN/SAPPHIRE
FOR FORMING LASER MIRROR FACETS

Examiner: S. Ahmed

**STATEMENT OF SUBSTANCE OF INTERVIEW IN
ACCORDANCE WITH MPEP §713.04**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants submit herewith a statement on the substance of the telephonic interview held on December 11, 2006.

It is noted in the Examiner's Amendment, and was agreed upon between Examiner Ahmed and applicant's representative that non-elected claim 19 would be cancelled.

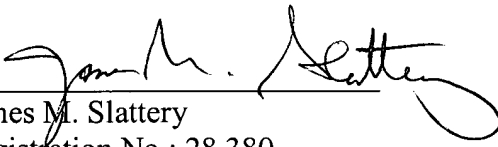
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If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Dated: January 16, 2007

Respectfully submitted,

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